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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Taketomi ASAMI et al.

Serial No. 09/842,315

Filed: April 26, 2001

For: MANUFACTURING METHOD

FOR SEMICONDUCTOR

DEVICE

Art Unit: 2813

Examiner: D. Blum

CERTIFICATE OF MAILING

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The United States Postal Service with sufficient postage as First
Class Mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450, on 5-12-2003

*Adam D. Stanger*AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 13, 2003, please amend the
above-identified application as follows:

IN THE CLAIMS:

Please amend claims 1-15 as follows:

1. (Amended) A method for manufacturing a semiconductor device
comprising:

the first step of forming a semiconductor film over a substrate;

the second step of forming a thin oxide film on a surface of the semiconductor
film by applying water in which ozone is dissolved;

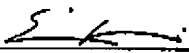
the third step of etching the semiconductor film to remove the thin oxide film and
contaminant impurities on the surface of the semiconductor film by applying an etching
solution while spinning the substrate; and

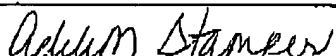
the fourth step of forming a gate insulating film in contact with the semiconductor
film after the third step,

PTO/SB/21 (08-00)

TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>		Application Number	09/842,315
		Filing Date	April 26, 2001
		First Named Inventor	Taketomi ASAMI et al.
		Group Art Unit	2813
		Examiner Name	D. Blum
Total Number of Pages in This Submission		Attorney Docket Number	0756-2306

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input checked="" type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Declaration and Power of Attorney <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation <input type="checkbox"/> Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s)	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input type="checkbox"/> Other Enclosures 1. 2. 3. 4. 5. 6.
Remarks <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge any additional fees required or credit any overpayments to Deposit Account No. 50-2280 for the above identified docket number.		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Eric J. Robinson, Reg. No. 38,285 Robinson Intellectual Property Law Office, P.C. PMB 955 21010 Southbank Street Potomac Falls, VA 20165
Signature	
Date	5-12-03

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Signature		Date	5-12-2003

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This will acknowledge receipt of the following:

1. Transmittal Form (2 copies)
2. Amendment
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In re PATENT application of:

TAKETOMI ASAMI et al
Serial No. 09/842,315
Filed: 04/26/2001
Due Date: 05/13/2003
For: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE

Docket: 0756-2306

5-12-2003

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